



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

April 22, 2025

IGI Report Number

DESCRIPTION

Shape and Cutting Style

Measurements

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

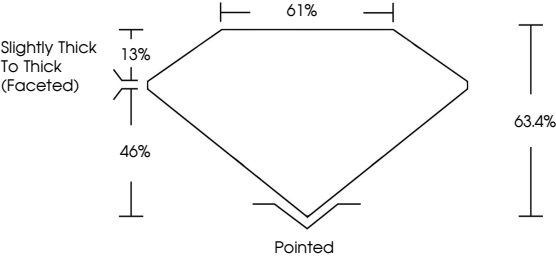
Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG700507422

Report verification at igi.org

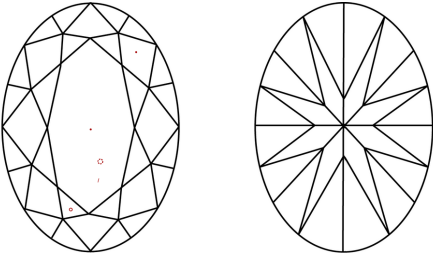
PROPORTIONS





Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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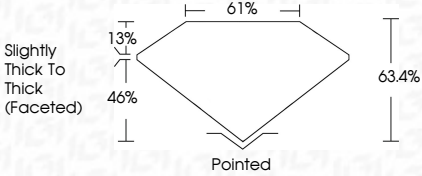
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IGI



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April 22, 2025

IGI Report No LG700507422

OVAL BRILLIANT

12.39 X 9.01 X 5.71 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Slightly Thick To Thick (Faceted)

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

4.02 CARATS

H

VS 1

63.4%

61%

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG700507422

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